



Docket No. 740819-568

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of: )

Yoshiyuki TANI )

Serial No. 09/874,367 )

Filed: June 6, 2001 )

For: PHOTOMASK MAKING METHOD )  
AND ALIGNMENT METHOD )

Group Art Unit: 1756

Examiner: Christopher G. Young

Confirmation No. 2951

**CERTIFICATE OF MAILING OR TRANSMISSION**

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\_\_\_\_\_  
Angelique Graham

**AMENDMENT AFTER FINAL OFFICE ACTION**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the final Office Action mailed October 20, 2003, please consider the following amendments and remarks in connection with the above-identified application.